Electronic Supplementary Information

MoSe₂ Quantum Dots Modified Hole Extraction Layer Enables Binary Organic Solar Cells with Improved Efficiency and Stability

Hong Lian,^{‡a,b} Mingao Pan,^{‡c} Jinba Han,^a Xiaozhe Cheng,^a Jiaen Liang,^c Wenqiang Hua,^d Yongquan Qu,^a Yucheng Wu,^a Qingchen Dong,^{*a,b} Bin Wei,^{*b} He Yan,^{*c} and Wai-Yeung Wong^{*e}

^aMOE Key Laboratory of Interface Science and Engineering in Advanced Materials, Taiyuan University of Technology, 79 Yingze West Street, Taiyuan, 030024, China. E-mail: dongqingchen@tyut.edu.cn.

^bMOE Key Laboratory of Advanced Display and System Applications, Shanghai University, Shanghai, 200072, China. E-mail: bwei@shu.edu.cn.

^cDepartment of Chemistry and Hong Kong Branch of Chinese National Engineering Research Center for Tissue Restoration & Reconstruction, Hong Kong University of Science and Technology, Clear Water Bay, Kowloon, Hong Kong. China. E-mail: hyan@ust.hk.

^dShanghai Advanced Research Institute, Chinese Academy of Sciences, 201210, China.

^eDepartment of Applied Biology and Chemical Technology and Research Institute for Smart Energy (RISE), The Hong Kong Polytechnic University, Hung Hom, Hong Kong, China, E-mail: waiyeung.wong@polyu.edu.hk

[‡]*These people contribute equally to this work.*

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Fig. S13. J-V curves based on the blend system (a) P3HT/PC₆₁BM, and (b) PTB7-Th/PC₇₁BM.

Liquid	Dispersion force $[V_L^d]$	Polar force [V ^P _L]	Surface energy [^{V_L}]
Water	22.1	50.7	72.8
EG	29.3	18.9	48.2

Table S1. Parameters of the testing liquids of water and EG.

Table S2. The contact angle and surface energy of different materials.

Matarial	Watan contact angle	FC contest angle	Surface energy	
wateriai	water contact angle	EG contact angle	[mN m - 1]	
ITO	32.0°	23.0°	68.8	
MoSe ₂	30.0°	13.0°	70.0	
PEDOT:PSS	17.0°	24.0°	85.5	
MoSe ₂ /PEDOT:PS	15.0°	22.0°	89.0	
S				
PM6:Y6	98.5°	64.0°	40.9	

Table S3. The interface energy between two different materials.

Material	Interfacial energy [mN m - 1]
ITO/PEDOT:PSS	4.42
MoSe ₂ /PEDOT:PSS	7.54
PEDOT:PSS/PM6:Y6	121.0
MoSe ₂ /PEDOT:PSS/PM6:Y6	128.4

Table S4. Summary of device performances of PM6:Y6 based OSCs without or with MoSe₂

Layer ^a	<i>J_{sc}</i> [mA cm ⁻²]	V _{oc} [V]	FF [%]	PCE [%]	$R_s [\Omega \cdot cm^2]$
PEDOT:PSS	24.68	0.84	74.29	15.48 (15.18±0.2) ^b	7.94
MoSe ₂ -4000r/PEDOT:PSS	25.68	0.83	73.76	15.68 (15.26±0.2) ^b	4.78
MoSe ₂ -5000r/PEDOT:PSS	25.83	0.83	74.34	15.92 (15.56±0.3) ^b	4.25
MoSe ₂ -6000r/PEDOT:PSS	25.84	0.83	74.69	16.08 (15.75±0.2) ^b	3.63
MoSe ₂ -7000r/PEDOT:PSS	25.69	0.83	75.03	16.00 (15.68±0.3) ^b	4.59

QDs with different rotation speeds.

^a For PEDOT:PSS, 3000 rotations per minute (r) were used. ^b Average PCE with standard deviations were obtained from 10 devices.

Table S5. Comparison of the device parameters of previously reported devices with 2D

 materials as the interface modifier.

Material	Synthetic method	Function of TMDs	Deposition method	Device structures	PCE (%)	Reference	
WS ₂	Sonication	HTL	Spin-coating	ITO/WS2/P3HT:PCBM/LiF/Al	2.40	[1]	
Bi ₂ Se ₃	Lithium intercalation	HTL	Spin-coating	ITO/ZnO/P3HT:PC ₆₁ BM/L-Bi ₂ Se ₃ /Ag	4.37	[2]	
MoS_2	Lithium intercalation	HTL	Spin-coating	ITO/MoS _x /P3HT:PCBM/LiF/Al	2.95	[3]	
MoS_2	Lithium intercalation	HTL	Spin-coating	ITO/ZnO/P3HT:PCBM/MoS ₂ /Ag ITO/ZnO/PTB7:PC ₇₁ BM/MoS ₂ /Ag	4.02 8.11	[4]	
NbSe ₂	Lithium intercalation	HTL	Spin-coating	ITO/ZnO/PTB7:PC71BM/NbSe2/Ag	8.10	[5]	
MoS ₂	Sonication	HTL	Spin-coating	ITO/MoS ₂ /P3HT:PCBM/LiF/Al	2.44	[6]	
MoS ₂ WS ₂	Sonication	HTL	Transferring	ITO/MoS _x /P3HT:PCBM/LiF/Al ITO/WS ₂ /P3HT:PCBM/LiF/Al	2.96 3.08	[7]	
	Lithium	HTL		ITO/p-doped MoS ₂ /P3HT:PCBM/Ca/Al	3.38		
MoS ₂	intercalation	ETL	Spin-coating	ITO/n-doped MoS ₂ /P3HT:PCBM/PEDOT:PSS/Ag	2.73	[8]	
In_2Se_3	Sonication	HTL	Spin-coating	ITO/α-In ₂ Se ₃ /PBDB-T:ITIC/Ca/Al	9.60	[9]	
MoS ₂	Sonication	ETL	Spin-coating	$ITO/MoS_2/PTB7\text{-}Th\text{:}PC_{71}BM/MoO_3/Al$	9.07	[10]	
BP	Liquid-phase exfoliation	HTL/ETL	Spin-coating	ITO/ZnO/BPQD1/PTB7-Th:FOIC//BPQD2/MoO ₃ /Al	13.10	[11]	
MoS ₂	Lithium intercalation	HTL	Spin-coating	ITO/MoS ₂ /PTB7:PC ₇₁ BM/PFN/Al	7.26	[12]	
MoS ₂	Lithium intercalation	HTL	Spin-coating	ITO/MoS ₂ /PTB7:PC ₇₁ BM/PFN/AI	7.64	[13]	
TaS	Sonication	HTL	Spin-coating	ITO/TaS ₂ /P3HT:PCBM/LiF/A1	3.06	[14]	
2		ETL		ITO/TaS ₂ /P3HT:PCBM/MoO ₃ /Al			
MoS ₂	Lithium intercalation	ETL	Spray-coating	ITO/ZnO/P3HT:PCBM/MoS ₂ /Al	2.04	[15]	
WSe ₂	Liquid-phase exfoliation	Third component	Spin-coating	ITO/PFN/PTB7:WSe ₂ :PCBM/MoO ₃ /Al	9.28	[16]	
MoS ₂	Salt-assisted exfoliation	HTL	Spin-coating	ITO/MoS ₂ /PBDTTT-CF:PC ₇₁ BM/Ca/Al	6.90	[17]	
MoSe ₂	Liquid-phase exfoliation	Third component	Spin-coating	ITO/ZnO/PTB7-TH:PC71BM:MoSe2/MoO3/Ag	10.44	[18]	
MoS_2	Liquid-phase	HTL	Spin-coating	ITO/MoS ₂ /PBDB-T-SF:IT-4F/PFN-Br/Al	12.00	[19]	
WS ₂	exionation			ITO/WS ₂ /PM6:Y6/PFN-Br/Al	15.80		
BiOCl	Sonication	HTL	Spin-coating	ITO/BIOCI/IPM6:V6/RDINO/AL	16.11	[20]	
	Liquid phase			ITO/ZnO/PBDB-T:ITIC:Bi ₂ O ₂ Se/MoO ₃ /Al	12.22		
Bi ₂ O ₂ Se	exfoliation	HTL	Spin-coating	ITO/ZnO/PM6:Y6:Bi ₂ O ₂ Se/MoO ₃ /Al	16.28	[21]	
GO/G	Micromechanical exfoliation	HTL/ETL	Spin-coating	ITO/PEDOT:PSS-GO/PTQ10:IDIC-2F/PDINO-G/AI ITO/PEDOT:PSS-GO/PM6:Y6/PDINO-G/AI	13.01 16.52	[22]	
In S-	Sonication	ЦТІ	Spin anti-	ITO/PEDOT:PSS:In ₂ Se ₃ /PBDB-T:ITIC/PFN-Br/Al	11.22	[22]	
m ₂ Se ₃	Someation	Spin-coating	Someation HTL	Spin-coating	ITO/PEDOT:PSS:In ₂ Se ₃ /PM6:Y6/PFN-Br/Al	15.89	[23]
g-C3N4	Centrifugation	HTL	Spin-coating	ITO/g-C3N4:PEDOT:PSS/PM6:Y6/PFN-Br/Ag	16.38	[24]	
MoSe ₂	Lithium intercalation	HTL	Spin-coating	ITO/MoSe ₂ /PEDOT:PSS/PM6:Y6/PFN-Br/Al ITO/MoSe ₂ /PEDOT:PSS/SZ2:N3/PFN-Br/Al	16.08 17.08	This work	

Table S6. Hole mobility and conductivity of the hole-only devices as measured by SCLC

 method and van der Pauw four-probe conductivity technique, respectively.

Device	Hole mobility μ_h [cm ² V ⁻¹ s ⁻¹]	Conductivity [S cm ⁻¹]
ITO/PEDOT:PSS/PM6:Y6/MoO ₃ /Al	6.30×10 ⁻⁵	6.23×10 ⁻⁴
ITO/ MoSe ₂	2.26×10 ⁻⁴	9.76×10 ⁻⁴
QDs/PEDOT:PSS/PM6:Y6/MoO ₃ /A1		

Table S7. Photovoltaic parameters of the optimal OSCs based on PBDB-T/ITIC, PTB7-

Th/PC₇₁BM, and P3HT/PC₆₁BM with and without MoSe₂ QDs.

BHJ	Description	J_{sc} [mA cm ⁻²]	V _{oc} [V]	FF [%]	PCE [%]
PBDB-T:ITIC	PEDOT:PSS	15.40 (15.32±0.2)	0.89	69.55	9.51
			(0.88±0.01)	(69.55±2.01)	(9.21±0.05)
	MoSe ₂ /PEDOT:PS	16 18 (15 48+0 2)	0.90	72.30	10.41
	S	10.10 (13.46±0.2)	(0.89±0.02)	(72.19±1.08)	(9.86±0.09)
	PEDOT:PSS 15	15 71 (15 66 0 2)	0.78	64.45	7.88
DTD7 TLDC DM		13.71 (13.00±0.3)	(0.77±0.01)	(62.07±3.12)	(7.49±0.07)
PIB/-Ih:PC ₇₁ BM	MoSe ₂ /PEDOT:PS	16 51 (16 24+0.2)	0.78	64.30	8.32
	S	$10.31(10.34\pm0.2)$	(0.78±0.01)	(62.12±2.06)	(7.92±0.08)
P3HT:PC ₆₁ BM	REDOTING	7 51 (7 26±0 2)	0.58	65.04	2.93
	reb01.rss	7.51 (7.20±0.5)	(0.58±0.01)	(63.86±1.06)	(2.77±0.14)
	MoSe ₂ /PEDOT:PS	8 02 (7 58 10 2)	0.59	63.58	3.24
	S	8.02 (7.58±0.2)	(0.58±0.01)	(62.16±1.02)	(2.98±0.16)

S1. Experimental details

1.1 Materials

PEDOT:PSS (Clevios PVP AI 4083, a weight ratio of 1:6) and MoSe₂ bulk material were bought from H.C. Starck. (2,2'-((2Z,2'Z)-((12,13-bis(3-ethylheptyl)-3,9-diundecyl-12,13-dihydro[1,2,5]thiadiazolo[3,4-e]thieno[2",3":4',5']thieno[2',3':4,5]pyrrolo[3,2-g]thieno [2',3':4,5]thieno[3,2-b]indole-2,10-diyl)bis(methanylylidene))bis(5,6-difluoro-3-oxo-2,3-

dihydro-1H-indene-2,1-diylidene))dimalononitrile (N3), SZ2 (as donor material), (poly[(2,6-(4,8-bis(5-(2-ethylhexyl-3-fluoro)thiophen-2-yl)-benzo[1,2-b:4,5-b']dithiophene))

-alt-(5,5-(1',3'-di2-thienyl-5',7'-bis(2-ethylhexyl)benzo[1',2'-c:4',5'-c']dithiophene-4,8-

dione)]), (PM6) and (2,20-((2Z,20Z)-((12,13-bis(2-ethylhexyl)-3,9-diundecyl-12,13-dihydro-

[1,2,5]thiadiazolo[3,4-e]thieno[200,300:40,50]thieno[20,30:4,5]pyrrolo[3,2-g]thieno

[20,30:4,5]thieno[3,2-b]indole-2,10-diyl)bis (methanylylidene))-bis(5,6-diiluoro-3-oxo-2,3dihydro-1H-indene-2,1- diylidene))dimalononitrile) (Y6) were purchased from eFlexPV Limited Inc. Poly[(2,6-(4,8-bis(5-(2-ethylhexyl)thiophen-2-yl)benzo[1,2-b:4,5-b']dithiophene)co-(1,3-di(5-thiophene-2-yl)-5,7-bis(2-ethylhexyl)benzo[1,2-c:4,5-c']dithiop

hene-4,8-dione)] (PBDB-T), 3,9-bis(2-methylene(3-(1,1-dicyanomethylene) -indanone))-5,5,11,11-tetrakis(4-hexylphenyl)dithieno-[2,3-d:2',3'-d']-s-indaceno[1,2-b:5,6-b']dithiophene (ITIC), poly[9,9-bis(6'-bromohexyl)fluorene-alt-co-1,4-phenylene (PFN-Br) were obtained from Solarmer Materials Inc. Poly({4,8-bis[(2-ethylhexyl)oxy]benzo[1,2-b:4,5b']dithiophene-2,6-diyl} {3-fluoro-2-[(2-ethylhexyl)-carbonyl]thieno[3,4-b]thiophenediyl}) (PTB7-Th), [6,6]-phenyl-C₇₁-butyricacid methyl ester (PC71BM), poly(3-hexylthiophene) (P3HT) and [6,6]phenyl-C₆₁-butyric acid methyl ester (PC61BM) were purchased from 1-Material Inc.1-chloronaphthalene (CN) and chlorobenzene (CB) were supplied by Sigma-Aldrich. All these commercial materials were used directly without further treatment.

1.2 Synthesis of MoSe₂ QDs

MoSe₂ QDs were synthesized using a lithium intercalation method as reported previously in the literature.^[33] In the glove box, 0.5 g MoSe₂ bulk material was added into 5 mL of 2.2M n-butyl lithium solution and stirred evenly for two days, so that lithium ions

could fully enter into the interlayers of the MoSe₂ bulk material and form the Li_xMoSe₂ species. Then the Li_xMoSe₂ compound was retrieved by filtration and washed with hexane several times to remove excess lithium and organic residues. Li_xMoSe₂ was ultrasonicated in water for 3 h and the mixture was dialyzed in water for 2 days to remove LiOH and unexfoliated materials. The as-prepared MoSe₂ QDs that emitted weak blue fluorescence were collected by further centrifugation at 12,000 rpm for 20 min. The sample was diluted with deionized water to a concentration of about 0.5 mg/mL for device fabrication.

1.3 Device fabrication

OSCs were fabricated on a patterned ITO/glass substrate with a sheet resistance of 20 Ω /square. Substrates were cleaned via sonication sequentially in deionized water, acetone and isopropanol for 20 min, and then dried using a pure nitrogen gas stream and exposed to UV-ozone for 15 min prior to the device fabrication. The MoSe₂ QDs solution was first spin coated on the ITO substrate at different speeds (4000-7000 rpm) for 60 s and then annealed on a hot plate at 300 °C for 15 min in air to remove the water. Next, as-received PEDOT:PSS suspensions were subsequently spin-coated onto the above substrates at 4000 rpm for 60 s (thickness ~ 40 nm), and then annealed at 130 °C for 20 min in air. Afterwards, the substrates were transferred into a N₂-filled glove box. The pre-prepared active layer (PM6:Y6 dissolved in CN) blend solution were spin coated (2000 rpm, 30 s) on the HEL films in the N₂-filled glove box, followed by heating at 100 °C for 10 min. After that, PFN-Br dissolved in methanol (0.5 mg mL⁻¹) and was spun on top of the BHJ layer at 4000 rpm for 30s. Finally, the samples were transferred into a thermal vacuum evaporator for the deposition of Al (100 nm) under high vacuum (5.0×10⁻⁴ Pa). The active area of the pixel was approximately 4 mm²,

which was strictly patterned by a shadow mask. For the sake of comparison, structurally identical control OSCs with a pure PEDOT:PSS anode contact were also fabricated.

1.4 Device Characterization

The intensity of the solar simulator was determined by a standard Si photovoltaic cell calibrated by the National Renewable Energy Laboratory. The current density (*J*)-voltage (*V*) characteristics were recorded with a Keithley 2420 source meter in the dark and under illumination using a solar simulator with an AM 1.5G simulated solar spectrum. The J-V curve of the device is measured every 30 s. The measurement interval is 20 mV. The EQE spectra were measured using a 7-SCSpec solar cell measurement system. All the measurements were performed in air under ambient conditions without device encapsulation. The dependence curve of the J-V under different light intensities was measured using a standard Si solar cell combination with a neutral density sieve.

The atomic force microscopic (AFM) images and scanning electron microscopic (SEM) images were collected using a Nanonavi SPA-400SPM AFM in the tapping mode and a Philips scanning electron microscope, respectively. Transmission electron microscopy (TEM) and high-resolution TEM (HR-TEM) images were recorded by JEM-2100F and energy dispersive X-ray spectroscopy (EDS) operated at 200 kV. The UV-visible absorption and transmission spectra were taken with UV–vis spectrophotometer (HP 8453). A Hitachi F-7000 spectrofluorophotometer was utilized for the photoluminescence (PL) spectra. The TRPL spectra were measured by the FLS980 Spectrometer. The X-ray photoelectron spectra (XPS) and ultraviolet photoelectron spectra (UPS) were obtained with an Axis Ultra DLD X-ray photoelectron spectrometer equipped with an Al Kα X-ray source (1486.6 eV) and He I

(21.22 eV), respectively. The grazing incidence small-angle X-ray scattering (GISAXS) and grazing incidence wide-angle X-ray scattering (GIWAXS) measurements of the pre-prepared samples were performed using an incident angle of 0.2° at the BL14B station of the Shanghai Synchrotron Radiation Facility (SSRF). The electrochemical impedance spectroscopy (EIS) was measured using an electrochemical workstation in the frequency range between 0.1 Hz and 1.0 MHz

S2. The XPS characterization of post heat-treated thin film of MoSe₂ QDs

By analyzing the peak areas of 3d peaks of Mo and Se, the Mo:Se ratio was calculated to be 1:1.76, which is less than the nominal value of 1:2, indicating the presence of a large amount of selenium vacancies and edge structures in MoSe₂ QDs. The peaks at 228.3 and 231.4 eV are inferred from Mo⁴⁺ $3d_{5/2}$ and Mo⁴⁺ $3d_{3/2}$, respectively, while the peaks at 54.6 and 55.4 eV can be attributed to Se²⁻ $3d_{5/2}$ and Se²⁻ $3d_{3/2}$ orbits, which match well with the 2H-MoSe₂ QDs phase.^[25] As a result, we induced that there are a few MoO₃ species existing, probably at the MoSe₂/PEDOT:PSS interface. Compared to the previous reports, the significant oxidation in MoSe₂ QDs as confirmed by peaks of Mo⁶⁺ and Se⁴⁺ in XPS spectra is attributed to the high-temperature annealing process of MoSe₂ QDs.^[26] Fig. S2c shows O 1s core level peaks in 530.7 and 528.9 eV, fitted with the Gaussian-Lorentzian function, corresponding to the adsorbed oxygen and lattice oxygen, respectively. The former is mainly physically adsorbed due to the electronegativity of MoSe₂ QDs, which can easily disappear in a high vacuum condition. The latter is derived from the redox reaction of the MoSe₂ QDs. It is reported that the O incorporation not only could partially fill the Se vacancies and passivate the structural defects, but lead to a change of interfacial energy level alignment (change ntype MoSe₂ to p-type), which is beneficial to device efficiency and stability (see Fig. 2d).^[27] Based on the above discussion, we suspect that Mo⁶⁺ mainly comes from the oxidation of the selenium vacancies and edge structures and speculate that the reaction equation is as follows:

$$MoSe_2 + O_2 \rightarrow MoO_3 + MoSe_xO_{3-x} + SeO_2(0 \le x \le 3)$$

S3. The calculation of G_{max} and P(E,T)

 J_{ph} is defined as $J_{light} - J_{dark}$, where J_{light} and J_{dark} are the current densities under illumination and in dark state, respectively.^[29] V_{eff} is determined as $V_{eff} = V_0 - V_{app}$, where V_0 is the built-in potential and V_{app} is the applied bias voltage. The curve is divided into two distinct regions. J_{ph} firstly increases almost linearly with V_{eff} in the low effective voltage regime. Then, it gradually reaches a saturated photocurrent (J_{sat}) when $V_{eff} \ge 0.2$ V. Assuming that all the photogenerated excitons are dissociated into free charge carriers and collected without the recombination loss under the high effective voltage, then the maximum exciton generation rate (G_{max}) could be determined by the equation $J_{sat} = qG_{max}L$, where q is the elementary charge and L is the BHJ thickness.^[28] The values of G_{max} based on PEDOT:PSS and MoSe₂ QDs/PEDOT:PSS HEL are calculated to be 9.65 $\times 10^{27}$ m 3 s $^{-1}$ for control cell, 1.04 \times 10 28 m $^{-3}$ s⁻¹ for MoSe₂ QDs-4000r/PEDOT:PSS, 1.05×10^{28} m⁻³ s⁻¹ for MoSe₂ QDs-5000r/PEDOT:PSS, 1.07×10^{28} m⁻³ s⁻¹ for MoSe₂ QDs-6000r/PEDOT:PSS, and 1.06×10^{28} m⁻³ s⁻¹ for MoSe₂ QDs-7000r/PEDOT:PSS, respectively, as shown in Fig. S5b. The enhanced G_{max} indicates that the embedded MoSe₂ QDs can promote light absorption in OSCs, leading to the increase of J_{sc} values. The exciton dissociation probabilities P(E,T) are estimated according to the following relationship: $J_{ph} = qG_{max} P(E,T)L$. The P(E,T) can also be obtained from the ratio of J_{ph}/J_{sat} . It turns out that the value of P(E,T) increases from 88.6% of the control cell to 93.8% of the MoSe₂ QDs-6000r/PEDOT:PSS-based cell, indicating that introduction of MoSe₂ QDs into cells contributes to improving the overall charge dissociation process and reducing charge recombination, and thereby achieving high PCE.

S4. The relationship of J_{sc} , V_{oc} and I

The relationship between J_{sc} and I can be described as $J_{sc} \propto I^{\alpha}$, where α is the index factor. A weaker bimolecular recombination process can be anticipated for the OSC device if the value of α is approaching to 1.^[29] The relationship between V_{oc} and I can be expressed by the equation of $V_{oc} \propto n \, kT/q \, ln(I)$, where k, T, and q are the Boltzmann constant, the temperature in K, and the elementary charge, respectively.^[30] When bimolecular recombination dominates in the cell, the slope would be close to 1 kT/q, while for monomolecular recombination (trapassisted recombination) dominated cell, the slope would be close to 2 kT/q.^[11]

S5. The surface energy and interfacial energy calculations

The surface energy is calculated by using the following equation:

$$V_L = V_L^a + V_L^p \qquad \text{S5-1}$$

$$I + \cos\theta = 2(\sqrt{V_L^d} \cdot \frac{\sqrt{V_L^d}}{V_L} + \sqrt{V_L^p} \cdot \frac{\sqrt{V_L^p}}{V_L}) \qquad \text{S5-2}$$

where V_L represents pure material surface energy, V^d and V^P are dispersion force and polarity force. Surface energy (V_L) was determined by the contact angles of the testing liquids of water and EG, and the parameters of the testing liquids as Table S1-S3 as shown above. In light of the surface energy of two different materials, interfacial energy between two different materials can be determined according to the equation below:

$$V_{A-B} = V_A + V_B - 4\left(\frac{V_A^d \cdot V_B^d}{V_A^d + V_B^d} + \frac{V_A^p \cdot V_B^p}{V_A^p + V_B^p}\right)$$
S5-3

where V_A and V_B represent the surface energy of sample A and sample B, respectively; V_A^d and V_B^d are dispersion forces of sample A and sample B, respectively; V_A^p and V_B^p are polarity forces of sample A and sample B, respectively.

References

- 1. Q. V. Le, T. P. Nguyen and S. Y. Kim, Phys. Status Solidi RRL., 2014, 8, 390-394.
- 2. Z. Yuan, Z. Wu, S. Bai, W. Cui, J. Liu, T. Song and B. Sun, Org. Electron., 2015, 26, 327-333.
- Q. Van Le, T. P. Nguyen, M. Park, W. Sohn, H. W. Jang and S. Y. Kim, *Adv. Opt. Mater.*, 2016, 4, 1796-1804.
- X. Gu, W. Cui, H. Li, Z. Wu, Z. Zeng, S.-T. Lee, H. Zhang and B. Sun, *Adv. Energy Mater.*, 2013, 3, 1262-1268.
- 5. X. Gu, W. Cui, T. Song, C. Liu, X. Shi, S. Wang and B. Sun, ChemSusChem, 2014, 7, 416-420.
- Q. V. Le, T. P. Nguyen, H. W. Jang and S. Y. Kim, *Phys. Chem. Chem. Phys.*, 2014, 16, 13123-13128.
- K. C. Kwon, C. Kim, Q. V. Le, S. Gim, J.-M. Jeon, J. Y. Ham, J.-L. Lee, H. W. Jang and S. Y. Kim, ACS Nano, 2015, 9, 4146-4155.
- J.-M. Yun, Y.-J. Noh, J.-S. Yeo, Y.-J. Go, S.-I. Na, H.-G. Jeong, J. Kim, S. Lee, S.-S. Kim, H. Y. Koo, T.-W. Kim and D.-Y. Kim, *J. Mater. Chem. C*, 2013, 1, 3777-3783.
- 9. J. Wang, H. Yu, C. Hou and J. Zhang, Solar RRL, 2020, 4, 1900428.
- K. S. Lee, Y. J. Park, J. Shim, C.-H. Lee, G.-H. Lim, H. Y. Kim, J. W. Choi, C.-L. Lee, Y. Jin, K. Yu, H.-S. Chung, B. Angadi, S.-I. Na and D. I. Son, *J. Mater. Chem. A*, 2019, 7, 15356-15363.

- 11. Y. Wang, J. Li, T. Li, J. Wang, K. Liu, Q. Jiang, J. Tang and X. Zhan, Small, 2019, 15, 1903977.
- 12. W. Liu, X. Yang, Y. Zhang, M. Xu and H. Chen, RSC Adv., 2014, 3, 32744.
- X. Yang, W. Fu, W. Liu, J. Hong, Y. Cai, C. Jin, M. Xu, H. Wang, D. Yang and H. Chen, *J. Mater. Chem. A*, 2014, 2, 7727-7733.
- Q. V. Le, T. P. Nguyen, K. S. Choi, Y.-H. Cho, Y. J. Hong and S. Y. Kim, *Phys. Chem. Chem. Phys.*, 2014, 16, 25468-25472.
- D. Barrera, A. Jawaid, T. B. Daunis, L. Cheng, Q. Wang, Y.-J. Lee, M. J. Kim, J. Kim, R. A. Vaia and J. W. P. Hsu, *Mater. Today Energy*, 2017, 5, 107-111.
- G. Kakavelakis, A. E. Del Rio Castillo, V. Pellegrini, A. Ansaldo, P. Tzourmpakis, R. Brescia, M. Prato, E. Stratakis, E. Kymakis and F. Bonaccorso, *ACS Nano*, 2017, **11**, 3517-3531.
- H.-C. Wang, Y.-C. Lin, C.-H. Chen, C.-H. Huang, B. Chang, Y.-L. Liu, H.-W. Cheng, C.-S. Tsao and K.-H. Wei, *Nanoscale*, 2019, 11, 17460-17470.
- J.-M. Yun, Y.-J. Noh, C.-H. Lee, S.-I. Na, S. Lee, S. M. Jo, H.-I. Joh and D.-Y. Kim, *Small*, 2014, 10, 2319-2324.
- Y. Lin, B. Adilbekova, Y. Firdaus, E. Yengel, H. Faber, M. Sajjad, X. Zheng, E. Yarali, A. Seitkhan,
 O. M. Bakr, A. El-Labban, U. Schwingenschlögl, V. Tung, I. McCulloch, F. Laquai and T. D. Anthopoulos, *Adv. Mater.*, 2019, **31**, 1902965.
- B. Liu, Y. Wang, P. Chen, X. Zhang, H. Sun, Y. Tang, Q. Liao, J. Huang, H. Wang, H. Meng and X. Guo, ACS Appl. Mater. Interfaces, 2019, 11, 33505-33514.
- 21. C. Huang and H. Yu, ACS Appl. Mater. Interfaces, 2020, 12, 19643-19654.
- 22. F. Pan, C. Sun, Y. Li, D. Tang, Y. Zou, X. Li, S. Bai, X. Wei, M. Lv, X. Chen and Y. Li, *Energy Environ. Sci.*, 2019, **12**, 3400-3411.

- 23. J. Wang, H. Yu, C. Hou and J. Zhang, ACS Appl. Mater. Interfaces, 2020, 12, 26543-26554.
- Q. Yang, S. Yu, P. Fu, W. Yu, Y. Liu, X. Liu, Z. Feng, X. Guo and C. Li, *Adv. Funct. Mater.*, 2020, 30, 1910205.
- L. Yuwen, J. Zhou, Y. Zhang, Q. Zhang, J. Shan, Z. Luo, L. Weng, Z. Teng and L. Wang, Nanoscale, 2016, 8, 2720-2726.
- C. Xu, S. Peng, C. Tan, H. Ang, H. Tan, H. Zhang and Q. Yan, J. Mater. Chem. A, 2014, 2, 5597-5601.
- L. Liu, Y. Kan, K. Gao, J. Wang, M. Zhao, H. Chen, C. Zhao, T. Jiu, A.-K.-Y. Jen and Y. Li, *Adv. Mater.*, 2020, **32**, 1907604.
- J. Xiao, M. Ren, G. Zhang, J. Wang, D. Zhang, L. Liu, N. Li, C. J. Brabec, H.-L. Yip and Y. Cao, Solar RRL, 2019, 3, 1900077.
- 29. L. J. A. Koster, V. D. Mihailetchi, R. Ramaker and P. W. M. Blom, *Appl. Phys. Lett.*, 2005, **86**, 123509.
- 30. S. R. Cowan, A. Roy and A. J. Heeger, Phys. Rev. B, 2010, 82, 245207.